

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.:	10/644,116)	
)	Conf. No.: 6516
Filed:	August 20, 2003)	
)	
Title:	Whole-Wafer)	
	Photoemission Analysis)	
)	
Inventors:	Jeffrey Blackwood et al.)	
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Art Unit:	2624)	
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Examiner:	Daniel G. Mariam)	
)	
Atty. Ref:	03-0515)	

RESPONSE TO THE OFFICE ACTION MAILED NOVEMBER 6, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In the matter of the above-identified application and in response to the Office Action mailed November 6, 2006, kindly enter the following amendments and consider the following remarks toward reconsideration of the present application. A Petition for Extension of Time is enclosed, extending the deadline for responding to the Office Action to March 6, 2007.

Therefore, this Response is considered timely.